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PATENT

IN THE UNITED STATES DESIGNATED OFFICE (DO/US)

PCT/US2004/023869

INTERNATIONAL APPLICATION NO.

26 July 2004 (26.07.2004)

INTERNATIONAL FILING DATE

25 July 2003 (25.07.2003)

PRIORITY DATE CLAIMED

TITLE OF INVENTION

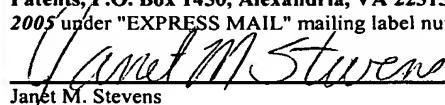
SEMICONDUCTOR ELEMENTS HAVING ZONES OF REDUCED OXYGEN

APPLICANT(S) FOR DO/US

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Mail Stop PCT
Attention: DO/US
Commissioner for Patents
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Janet M. Stevens

PRELIMINARY AMENDMENT

Sir:

Prior to examination, please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.